



IFW

P/1250-260

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Tatsufumi KUSUDA et al.

Serial No.: 10/661,240

Date Allowed: September 22, 2005

Filed: September 11, 2003

Date: October 21, 2005

For: PHOTOIRRADIATION THERMAL PROCESSING APPARATUS AND THERMAL
PROCESSING SUSCEPTOR EMPLOYED THEREFOR

Group Art Unit: 3742

Examiner: Shawntina T. FUQUA

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT AFTER ALLOWANCE

Sir:

Enclosed please find a copy of art, along with a form listing the same for the convenience of the Examiner. The present Information Disclosure Statement is being submitted after receipt of a Notice of Allowance, but before payment of the Issue Fee.

I certify that each item of information contained in the present Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to filing the present Statement. Our check no. 22270 including the fee of \$180.00 for filing the present Information Disclosure Statement subsequent to a Notice of Allowance, but before payment of the Issue Fee is enclosed.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 21, 2005
MAX MOSKOWITZ

Name of applicant, assignee or
Registered Representative

Signature
October 21, 2005
Date of Signature

Respectfully submitted,

MAX MOSKOWITZ
Registration No.: 30,576
OSTROLENK, FABER, GERB & SOFFEN, LLP
1180 Avenue of the Americas
New York, New York 10036-8403
Telephone: (212) 382-0700

10/25/2005 HDESTA1 000726327 10661240
01 FC:1006

APPLICANT'S ART CITATION <i>(Use several sheets if necessary)</i>		Application 10/661,240	OFGS File No. P/1250-260			
		Applicant Tatsufumi KUSUDA et al.				
		Filing Date September 11, 2003	Group Art Unit 3742			
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation
						Yes
<i>SJF</i>	2000-12370	07-2000	Korea			X
<i>SJF</i>	1999-84603	12-1999	Korea			X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
<i>SJF</i>	Untranslated Korean Office Action issued August 29, 2005 in connection with corresponding Korean application no. 10-2003-0082856					
<i>SJF</i>	English statement of Examiner's assertion in 8/29/05 Korean Office Action of the relevancy of Korean Application No. 1999-84603 to application no. 10-2003-0082856					
<i>SJF</i>	English statement of Examiner's assertion in 8/29/05 Korean Office Action of the relevancy of Korean Application No. 2000-12370 to application no. 10-2003-0082856					
<i>SJF</i>	Examiner <i>Tatsufumi Kusuda</i> Date Considered <i>4/20/06</i>					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						